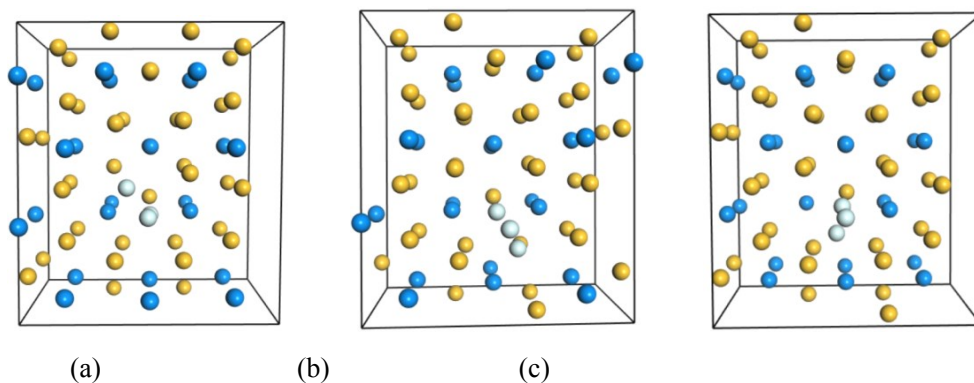
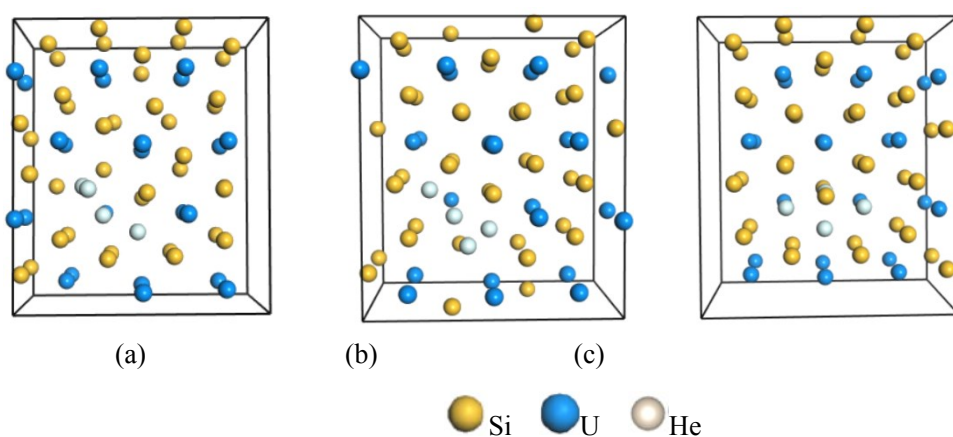


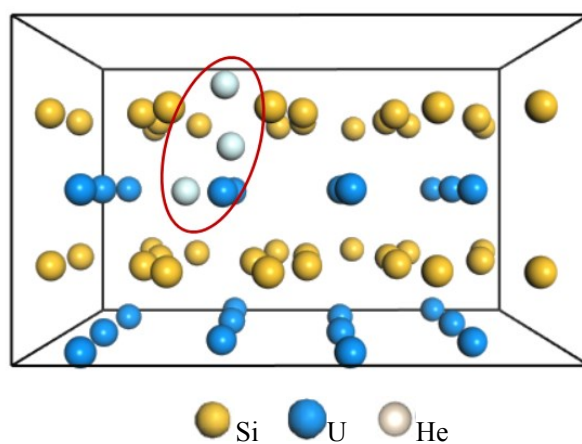
## Appendix A



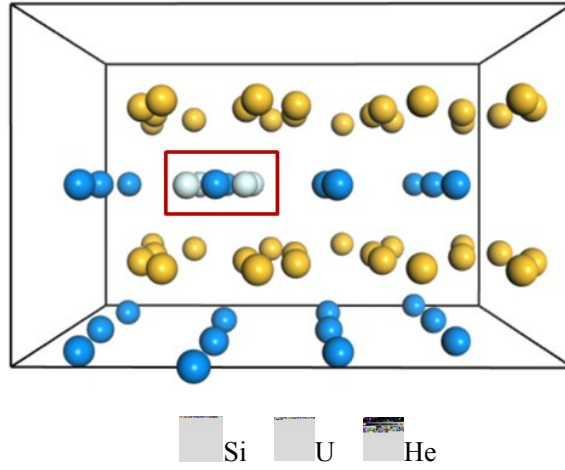
**Figure A1.** The optimized structures of the secondary defects Nearest Si<sub>1</sub> (a), Nearest Si<sub>2</sub> (b) and Nearest U (c) associated with primary Si<sub>2</sub> vacancy and 3 He atoms.



**Figure A2.** The optimized structures of the secondary defects Nearest Si<sub>1</sub> (a), Nearest Si<sub>2</sub> (b) and Nearest U (c) associated with primary U vacancy and 4 He atoms



**Figure A3.** The optimized configuration of 3 He atoms trapped in Si<sub>2</sub> vacancy.



**Figure A4.** The optimized configuration of 4 He atoms trapped in U vacancy.

## Appendix A

**Tab. A1** Lattice constant change and volume change associated with the He trapping in various interstitial sites

Structure	$a(\text{\AA})$	$b(\text{\AA})$	$c(\text{\AA})$	$V(\text{\AA}^3)$	$\Delta a/a(\%)$	$\Delta b/b(\%)$	$\Delta c/c(\%)$	$\Delta V/V(\%)$
$\text{U}_3\text{Si}_5$	13.23	8.05	11.39	1213.60	0	0	0	0
1a	13.25	8.05	11.42	1218.85	0.15	0	0.26	0.43
3g	13.38	7.98	11.59	1237.74	1.13	-0.86	1.70	1.99
2c	13.11	8.29	11.31	1229.09	-0.91	2.98	0.70	1.28
6i	13.30	8.03	11.45	1223.89	0.57	-0.25	0.53	0.85